



Our Ref. No.: 003531.P011

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
)
Jan-Jaco Marco Wieland et al.)
) Examiner: Fuller, Rodney Evan
Application No.: 10/692,632)
)
Filed: October 24, 2003) Art Unit: 2819
)
For: **LITHOGRAPHY SYSTEM**)
_____)

Mail Stop – RCE
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

Dear Commissioner:

Please amend the above-identified application as follows.

04/22/2005 MAHRED1 00000062 10692632
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